

AF/ 2823
IFW



Docket No.: 8733.307.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Oh-Nam Kwon

Confirmation: 4557

Application No.: 09/709,483

Art Unit: 2823

Filed: November 13, 2000

Examiner: T. V. Pham

For: METHOD OF MANUFACTURING A THIN
FILM TRANSISTOR

Customer: 30827

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated February 24, 2004 (Paper No. 0204), please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.